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## PATENT APPLICATION TRANSMITTAL LETTER

Docket Number: GOM-02001

To the Commissioner of Patents and Trademarks:

Transmitted herewith for filing under 35 U.S.C. 111 and 37 CFR 1.53 is the patent application of

Katsuhisa YUDA and Ge XU

Entitled: METHOD OF FORMING SILICON OXIDE FILM AND FORMING APPARATUS THEREOF

Enclosed are:

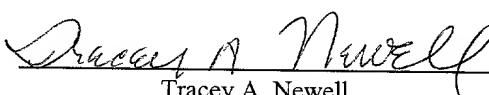
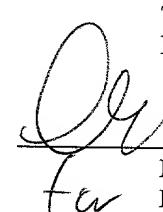
21 pages of written description, claims and abstract.  
 3 sheet of drawings.  
 an unexecuted Declaration

CLAIMS AS FILED

	NUMBER FILED	NUMBER EXTRA	RATE	FEE
BASIC FEE (37 CFR 1.16(a))			\$710	\$710
TOTAL CLAIMS (37 CFR 1.16(c))	14 - 20 =	*	\$ 18	\$
INDEPENDENT CLAIMS (37 CFR 1.16(b))	3 - 3 =	*	\$ 80	\$
MULTIPLE DEPENDENT CLAIM PRESENT		(37 CFR 1.16(d))	\$270	
NUMBER EXTRA MUST BE ZERO OR LARGER			TOTAL	\$710
	If applicant has small entity status under 37 CFR 1.9 and 1.27 then divide total fee by 2, and enter amount here.		SMALL ENTITY	\$

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I, do hereby certify that the foregoing documents are being deposited with the United States Postal Service as Express Mail, postage prepaid, "Post Office to Addressee", in an envelope addressed to the Commissioner for Patents, Box Patent Applications, Washington, D.C. 20231 on this date of March 27, 2001.

  
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